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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Kun-Tack Lee et al.

Group Art Unit: 1746

Serial No: 10/017,415

Examiner: Zeinab El Arini

Filed: December 18, 2001

For: SINGLE TYPE OF SEMICONDUCTOR WAFER CLEANING APPARATUS AND
METHOD OF USING THE SAME

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, Mail Stop Non-Fee Amendment
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

In response to the Office Action of March 5, 2004, Applicants elect the invention
of Group I, Claims 1-18, drawn to a single type of semiconductor wafer cleaning
apparatus. The election is without traverse.

Respectfully submitted,

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